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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10029039	12/20/2001	361		2836	

**APPLICANTS: Niu Feng; Chiou Wayne

**CONTINUING DATA VERIFIED:

BS N/A

** FOREIGN APPLICATIONS VERIFIED:

BS N/A

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	CM01545L
Verified and Acknowledged Examiner's initials BS			
TITLE : Reduced size, low loss MEMS torsional hinges and MEMS resonators employing such hinges			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL DISCLAIMER		Application Examiner		
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